

Docket No. 740756-2183

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Serial No. 09/620,968

Filed: July 20, 2000

For: METHOD OF FORMING INSULATING FILMS,
CAPACITANCES, AND SEMICONDUCTOR
DEVICES

)

) Group Art Unit: Nathan Ha

) Examiner: 2814

) Confirmation No. 4214

)

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[37 CFR 1.8(a)]

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Signature: 

Name: Pamela L. Patrick

PRELIMINARY AMENDMENT

Mail Stop RCE
Commissioner for Patents
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Alexandria, VA 22313-1450

Sir:

Further to the Applicants filing of the Request for Continued Examination (RCE) of February 28 2006, please preliminarily amend the subject application as follows.

W707046.1